

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Walter SCHWARZENBACH et al. Confirmation No.: 3337  
Application No.: 10/766,207 Group Art Unit: 2822  
Filing Date: January 29, 2004 Examiner: Khanh B. Duong  
For: METHOD OF DETACHING A LAYER FROM A Attorney Docket No.: 4717-11600  
WAFER USING A LOCALIZED STARTING  
AREA

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to applicants' duty of disclosure under 37 C.F.R. 1.56, enclosed is Form PTO-1449 which lists six (6) references for the Examiner's review and consideration. Copies of English abstracts are provided for the foreign patent documents.

It is respectfully requested that the references be made of record in this application by the Examiner's completion and return of the Form PTO-1449.

This Information Disclosure Statement is filed with a Request for Continued Examination. Accordingly, no fee is believed to be due. Should any fees be required, however, please charge such fee to Winston & Strawn LLP Deposit Account No. 50-1814.

Respectfully submitted,

5/21/07

Date

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